IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shannon V. Davidson

Serial No.:

10/824,873

Filing Date:

April 15, 2004

Group Art Unit: Confirmation No.: 2173 7114

Title:

Graphical User Interface for Managing HPC Clusters

Mail Stop: Amendments
Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Dear Sir:

Information Disclosure Statement

Applicant submits this Information Disclosure Statement (IDS) under 37 C.F.R. § 1.97(b)(3). Applicant respectfully requests the Examiner to consider and cite in the examination of this Application the documents listed in the attached Form PTO-1449. Under 37 C.F.R. § 1.98(a)(2)(ii), Applicant has provided copies of all references other than U.S. patents and U.S. patent application publications.

The Commissioner is hereby authorized to charge any fee and credit any overpayment to Deposit Account No. 02-0384 of Baker Botts L.L.P.

Respectfully submitted,

BAKER BOTTS L.L.P. Attorneys for Applicant

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Date: March 2, 2007

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DAL01:946722.1

PTO-1449 Information Disclosure Citation In an Application			Application No. 10/824,873		Applicant(s) Shannon V. Davidson	
			Docket Number 064747.1016	Group Art 2173		ling Date pril 15, 2004
		U	S. PATENT DOCUM	ENTS		
	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLAS	S FILING DATE
A						
B						
D					-	
	<u> </u>	FOR	EIGN PATENT DOCU	JMENTS		
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLAS	S TRANSLATION YES NO
		N	ON-PATENT DOCUM	ENTS	!	1110
	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
E	Hans-Ulrich Heiss, "Processor Management in Two-Dimensional Grid-Architectures," Interner Bericht Nr. 20/92, XP002416087, 51 pages					Dec. 1992
F	EPO Registered Letter, Application No. 05 252 239.8-1243, 6 pages 02.02.20					
G				<u> </u>		
H						
I						
J						
EXAMI	NER		DATE CONSIDERED			
EXAMINI considered	ER: Initial if citation considere	d, whether or not cit	ation is in conformance with MPI on to the applicant.	EP § 609. Draw line	through citation if	not in conformance and not

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